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BIBDATASHEET
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CONFIRMATION NO. 8479

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APPLICANTS								
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** CONTINUING DATA **********************************								
** FOREIGN APPLICATIONS ************************************								
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/18/2003								
Foreign Priority claime 35 USC 119 (a-d) conditions met	ed X yes □ no	after	STATE OR	SHEETS	TOTAL	INDEPENDI		
Verified and/ Acknowledged Examir	ler's Signature	Initials	COUNTRY JAPAN	DRAWING 4	CLAIMS 6	CLAIMS 2		

ADDRESS 25227 MORRISON & FOERSTER LLP 1650 TYSONS BOULEVARD SUITE 300 MCLEAN , VA 22102						
TITLE Multi-step local dry etching method for SOI wafer						
			□ All Fees			
FILING FEE No ACCOUN RECEIVED No			☐ 1.16 Fees (Filing)			
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